

Electronic Patent Application Fee Transmittal

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| Application Number: | 10585994 |
| Filing Date: | 13-Jul-2006 |
| Title of Invention: | MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE AND FILM DEPOSITION SYSTEM |
| First Named Inventor/Applicant Name: | Yasuo Kobayashi |
| Filer: | Michael A. Makuch/Cynthia Johnson |
| Attorney Docket Number: | 33082M336 |

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| Description | Fee Code | Quantity | Amount | Sub-Total in USD(\$) |
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| Basic Filing: | | | | |
| Pages: | | | | |
| Claims: | | | | |
| Miscellaneous-Filing: | | | | |
| Petition: | | | | |
| Patent-Appeals-and-Interference: | | | | |
| Post-Allowance-and-Post-Issuance: | | | | |
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